

00862.022435.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Re Application of:

KIYOSHI ARAKAWA

Appln. No.: 10/622,143

Filed: July 18, 2003

For: EXPOSURE APPARATUS,
MAINTENANCE METHOD
THEREFOR, SEMICONDUCTOR
DEVICE MANUFACTURING
METHOD USING THE APPARATUS,
AND SEMICONDUCTOR
MANUFACTURING FACTORY

Examiner: H. Nguyen

Group Art Unit: 2851

November 3, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THIRD INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

REMARKS

WO 99/50892 and JP-A-8-279459 were cited in a Korean Official Action of a counterpart foreign application corresponding to the above-referenced application. The Official Action is dated September 17, 2003. A copy of the Official Action is enclosed. Applicant respectfully submits that the WO document corresponds to EP 1 075 017 A1,

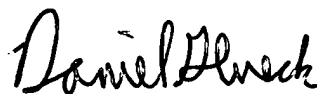
and the JP document corresponds to U.S. Patent No. 6,341,006. An Abstract for the JP document was obtained from a commercial database and is also enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

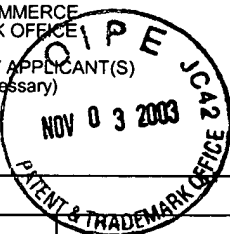
Respectfully submitted,



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DC_MAIN 148132 v 1

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Submitted: November 3, 2003			ATTY DOCKET NO. 00862.022435.1		APPLICATION NO. 10/622,143		
			APPLICANT KIYOSHI ARAKAWA				
			FILING DATE July 18, 2003		GROUP 2851		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,341,006 B1	01/22/02	Murayama, et al.	355	53	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		WO 99/50892	10/07/99	PCT			Abstract
		1 075 017 A1	7/02/01	Europe			
		8-279459	10/22/96	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

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